

10/591345
IAP9 Rec'd PCT/PTO 31 AUG 2006

033082M342

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shigeo ASHIGAKI, et al.

International Application No.: PCT/JP2005/003392

International Filing Date: March 1, 2005

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: PEELING-OFF METHOD AND REWORKING METHOD OF RESIST FILM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

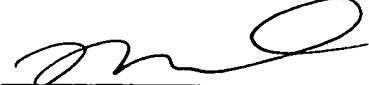
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists one of the documents noted in specification (U.S. Patent No. 6,316,167) and the documents noted in the International Search Report (ISR) filed herewith. Copies of the non-U.S. cited documents are enclosed. According to the Search Report, U.S. Patent No. 6,159,646 is a family member of JP 11-109654, U.S. Patent Publication No. 2003/0155077 is a family member of JP 2003-243295, Patent Publication 2003/0190550 is a family member of JP 2003-122009, U.S. Patent Publication 2002/0160590 is a family member of JP 2002-359352, U.S. Patent Publication No. 2003/0170993 is a family member of JP 2003-229481 and U.S. Patent Publication No. 2003/0157806 is a family member of JP 2003-167345.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:


Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

August 31, 2006

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M342	SERIAL NO. To Be Assigned
	APPLICANT: <p style="text-align: center;">Shigeo ASHIGAKI, et al.</p>	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	6,316,167	11/13/01	Angelopoulos, et al.			
	AB	6,159,646	12/12/00	Jeon et al.			
	AC	2003/0155077	8/21/03	Hisai, et al.			
	AD	2003/0190550	10/9/03	Nitta et al.			
	AE	2002/0160590	10/31/02	Hashimoto et al.			
	AF	2003/0170993	9/11/03	Nagahara et al.			
	AG	2003/0157806	8/21/03	Nagahara et al.			

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO	
	AH	11-109654	4/23/99	Japan			Abstract	
	AI	2003-243295	8/29/03	Japan			Abstract	
	AJ	2003-122009	4/25/03	Japan			Abstract	
	AK	2002-359352	12/13/02	Japan			Abstract	
	AL	2003-229481	8/15/03	Japan			Abstract	
	AM	2003-167345	6/13/03	Japan			Abstract	
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
AR	
AS	
EXAMINER:	DATE CONSIDERED:
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	